

Electronic Patent Application Fee Transmittal

Application Number:	09662219			
Filing Date:	14-Sep-2000			
Title of Invention:	PATTERN CORRECTING METHOD OF MASK FOR MANUFACTURING A SEMICONDUCTOR DEVICE AND RECORDING MEDIUM HAVING RECORDED ITS PATTERN CORRECTING METHOD			
First Named Inventor/Applicant Name:	Kei Yoshikawa			
Filer:	Richard V. Burgujian/Katherine Martin			
Attorney Docket Number:	04329.2409			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1440	1440
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Printed copy of patent - no color	8001	2	3	6
Total in USD (\$)				1446